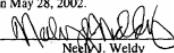


PATENT  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5 In re application of: ) Docket No: LAM1P077A  
Kuthi, et al. ) )  
Application No: 09/611,037 ) )  
10 Filed: July 6, 2000 ) )  
For: METHOD FOR MAKING A ) )  
SEMICONDUCTOR PROCESS ) )  
CHAMBER ELECTRODE ) )  
15 ) )  
6/13/02  
M



20 ) CERTIFICATE OF MAILING:  
I hereby certify that this correspondence is being deposited  
with the United States Postal Service as First Class Mail in an  
envelope addressed to: Commissioner for Patents, Washington  
DC 20231 on May 28, 2002.

Signed:   
Nedra Weldy

25 AMENDMENT

Commissioner for Patents  
Washington, D.C. 20231

30 Dear Sir:

Applicants submit this paper in response to the Office Action dated February 27, 2002. The period for response extends to May 28 2002. Please enter the following amendments and remarks:

35

IN THE DRAWINGS

Proposed amended Figures 1E and 2A are herein submitted with amendments shown in red. In Figure 1E, a first instance of the call-out "140" has been changed to "141." In Figure 2A, the call-out "256" is legibly inserted into the location from which it 40 was partially cut off in the originally submitted informal drawing.

